



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



CONFIRMATION NO. 2307

Bib Data Sheet

SERIAL NUMBER 10/528,137	FILING OR 371(c) DATE 12/12/2005 RULE	CLASS 118	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. 050161
-----------------------------	--	--------------	------------------------	----------------------------------

APPLICANTS

Takashi Ozaki, Tokyo, JAPAN;
 Tomoshi Taniyama, Tokyo, JAPAN;
 Hiroshi Unami, Tokyo, JAPAN;
 Kiyohiko Maeda, Tokyo, JAPAN;
 Shinya Morita, Tokyo, JAPAN;
 Yoshikazu Takashima, Tokyo, JAPAN;
 Sadao Hisakado, Tokyo, JAPAN;

** CONTINUING DATA *****

This application is a 371 of PCT/JP04/01996 02/20/2004 *M*

** FOREIGN APPLICATIONS *****

JAPAN 2003-44049 02/21/2003

JAPAN 2003-44904 02/21/2003

JAPAN 2003-87966 03/27/2003 *dr*

JAPAN 2003-87884 03/27/2003

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 9	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 6
35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance				
Verified and Acknowledged <i>Julia M. W. H. M.</i> Examiner's Signature Initials				

ADDRESS

23850

TITLE

Substrate-processing apparatus and method of producing a semiconductor device

FILING FEE RECEIVED 1630	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
-----------------------------	---	---